

**IN THE SPECIFICATION:**

**TITLE OF THE INVENTION:**

Please change the title of the invention to:

A DIAGNOSIS METHOD FOR SEMICONDUCTOR PROCESSING  
APPARATUS

**IN THE SPECIFICATION:**

Page 1, between the title of the invention and line 1, insert the following paragraph:

**CROSS REFERENCE TO RELATED APPLICATION**

This is a division of U.S. application Serial No. 10/229,072, filed August 28, 2002, the subject matter of which is incorporated by reference herein.